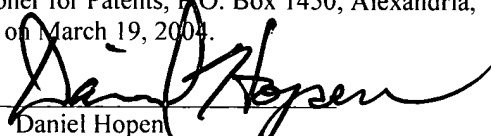




IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Talieh et al. Serial No.: 10/716,i16 Filed: November 18, 2003 Title: Method And System To Provide Material Removal And Planarization Employing A Reactive Pad	Group Art Unit: 1765 Examiner: Docket: NT-021D-US CERTIFICATE OF MAILING I hereby certify that this correspondence is being deposited with the US Postal Service as First Class Mail in a postage-paid envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313 on March 19, 2004. Signed:  Daniel Hopen
---	---

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Dear Sir:

Applicants submit information herewith to comply with the obligations set forth in 37 CFR §1.56. This submission is not an admission that any of the documents are prior art or otherwise relevant to the subject application.

This IDS is submitted:

- ☐ with a filed patent application or within 3 months of the US application filing date;
- ☒ before the mailing of a first office action on the merits;
- ☐ after the first office action, but prior to a final rejection or notice of allowance, and is accompanied by the fee set forth in 37 CFR §1.17(p) or a certification set forth below; or
- ☐ after a final rejection or notice of allowance, and is accompanied by the fee set forth in 37 CFR §1.17(p) and a certification set forth below, where this submission is a petition requesting consideration of this IDS.


If identified above, Applicant certifies that:

- ☐ the information was first cited in a communication from a foreign patent office in a counterpart foreign application less than 3 months prior to this IDS; or

[] to the knowledge of the person signing this certification after making reasonable inquiry, the information was not known to any individuals designated in 37 CFR §1.56 more than 3 months prior to this IDS.

If any matters can be resolved by telephone, Applicant requests that the Patent and Trademark Office call the Applicant at the telephone number listed below.

Respectfully submitted,

By: 
Daniel Hopan
Reg. No. 35,547

NuTool, Inc.
Legal Department
1655 McCandless Drive
Milpitas, CA 95035
(408) 586-9500x268



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

<p>In re application of:</p> <p>Talieh et al.</p> <p>Serial No.: 10/716,116</p> <p>Filed: November 18, 2003</p> <p>Title: Method And System To Provide Material Removal And Planarization Employing A Reactive Pad</p>	<p>Group Art Unit: 1765</p> <p>Examiner:</p> <p>Docket: NT-021D-US</p>
--	--

INFORMATION DISCLOSURE STATEMENT

US PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant	
	AA	4,098,031	July, 1978	Hartman et al.	In serial No. 09/969,531
	AB	4,323,656	April, 1982	Strickman et al.	In serial No. 09/969,531
	AC	5,167,747	Dec., 1992	Kadija	In serial No. 09/969,531
	AD	5,348,615	Sep., 1994	Gupta	In serial No. 09/969,531
	AE	5,665,252	Sep., 1997	Jin et al.	In serial No. 09/969,531
	AF	5,876,266	March, 1999	Miller et al.	In serial No. 09/969,531
	AG	5,929,526	July, 1999	Srinivasan et al	In serial No. 09/969,531
	AH	6,051,495	April, 200	Burke et al.	In serial No. 09/969,531
	AI	6,121,143	Sep., 2000	Messner et al.	In serial No. 09/969,531
	AJ	6,218,290	April, 2001	Schonauer et al.	In serial No. 09/969,531
	AK	6,313,038	Nov., 2001	Chopra et al.	In serial No. 09/969,531
	AL	6,383,065	May, 2002	Grumbine et al.	In serial No. 09/969,531
	AM	2002/0068516	Dec., 2000	Chen et al.	In serial No. 09/969,531

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant		

OTHER DOCUMENTS

Examiner Initials	Cite No.			Translation

Examiner Signature		Date Considered	